Special Issue

Experimental Mechanics, Instrumentation and Metrology

Message from the Guest Editors

Following the end of the Flomeko 2019 conference, the Scientific Committee will select a number of papers, based on their scientific originality and on the relevance of their topics, for publication in this Special Issue. Theoretical and experimental contributions, original and review studies, and industrial and university research will be welcome. The selected authors will then be invited to submit extended versions of their conference paper. The main topics include, but are not limited to the following: Prototyping and full-scale testing; NEMS and MEMS technologies; Instrumentation; data acquisition and processing; metrology; monitoring; experimental tests; measurements; optimum experimental techniques; study cases

Guest Editors

Prof. Dr. Teresa Leonor Martins Morgado

Dr. Álvaro Silva Ribeiro

Dr. Luís Filipe Lages Martins

Deadline for manuscript submissions

closed (30 June 2021)



Applied Sciences

an Open Access Journal by MDPI

Impact Factor 2.5 CiteScore 5.5



mdpi.com/si/27293

Applied Sciences Editorial Office MDPI, Grosspeteranlage 5 4052 Basel, Switzerland Tel: +41 61 683 77 34 applsci@mdpi.com

mdpi.com/journal/applsci





Applied Sciences

an Open Access Journal by MDPI

Impact Factor 2.5 CiteScore 5.5



About the Journal

Message from the Editor-in-Chief

As the world of science becomes ever more specialized, researchers may lose themselves in the deep forest of the ever increasing number of subfields being created. This open access journal Applied Sciences has been started to link these subfields, so researchers can cut through the forest and see the surrounding, or quite distant fields and subfields to help develop his/her own research even further with the aid of this multidimensional network.

Editor-in-Chief

Prof. Dr. Giulio Nicola Cerullo

Dipartimento di Fisica, Politecnico di Milano, Piazza L. da Vinci 32, 20133 Milano, Italy

Author Benefits

Open Access:

free for readers, with article processing charges (APC) paid by authors or their institutions.

High Visibility:

indexed within Scopus, SCIE (Web of Science), Ei Compendex, Inspec, CAPlus / SciFinder, and other databases.

Journal Rank:

JCR - Q2 (Engineering, Multidisciplinary) / CiteScore - Q1 (General Engineering)

